High-performance extended gate field-effect-transistor-based dissolved carbon dioxide sensing system with a packaged microreference electrode

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High-performance extended gate field-effect-transistor-based dissolved carbon dioxide sensing system with a packaged microreference electrode

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Abstract. We have developed an extended gate field-effect-transistor (EGFET)-based carbon dioxide (CO2) sensing system with a packaged Ti/Ag/AgCl/KCl-gel microreference electrode using microelectro-mechanical systems (MEMS) technology. The total dimensions of the proposed CO2 sensing system are only 2.8 x 1.5 x 0.1 cm, which is approximately 30 times smaller than a conventional CO2 sensing system (including the commercial Ag/AgCl RE). All of the manufacturing processes adopted in this work are compatible with standard planar technology and are very suitable for mass production. The presented planar reference electrode shows a very small offset voltage (~3.0 mV) and a very small potential drift (2.5 mV in 30,000 s) that is approximately equal to that of the commercial Ag/AgCl RE (1.6 mV in 30,000 s). Additionally, the implemented EGFET-based CO2 microsensor with a coated CO2 solid electrolyte and gas permeable membranes on the gate sensing area demonstrates a very high sensitivity (44.4 mV/decade) and very high sensing linearity (98.37%), while sensing CO2 concentrations ranging from 0.25 to 50 mM. Furthermore, a very small hysteresis voltage (7.5 mV) was obtained during the sensing cycle of 2.5–5–25–50–25–2.5 mM; this result was achieved by improving the surface planarization and enlarging the sensing area of the EGFET to 1 mm².

Keywords: extended gate field-effect-transistor; carbon dioxide microsensor; microreference electrode; microelectro-mechanical system; carbon dioxide solid electrolyte membrane; gas permeable membrane.

Paper 14082 received May 21, 2014; revised manuscript received Aug. 26, 2014; accepted for publication Aug. 28, 2014; published online Sep. 19, 2014.

1 Introduction

The large amount of carbon dioxide (CO2) produced by highly developed industries not only results in serious air pollution and health problems, but also causes ocean acidification and decreases the survival rate of fry in aquaculture.1,2 Therefore, the development of a system for real-time detection of CO2 concentrations in aquaculture has become a very important research issue. Optical analysis and gas chromatography are the two main methods adopted for conventional gas detection. Although conventional CO2 sensors have high sensitivity and accuracy, their high fabrication costs, large dimensions, low potential for batch fabrication, and lack of real-time monitoring functions can limit their applications.

To solve these problems, many publications have focused on the development of ion-sensitive field effect transistor (ISFET)-based ion-selective sensors, and various polymeric membranes and ionophores have been proposed over the past three decades.3,14 However, the extreme small sensing area of ISFETs usually results in an unacceptable hysteresis voltage and packaging problems. To overcome these disadvantages of ISFETs, this study has adopted an extended gate field-effect-transistor (EGFET) structure to isolate the FET from the chemical and biological environments.15–17 The sensing membrane is deposited on the end of the signal line extended from the FET gate electrode. The EGFET configuration presents many advantages, including light insensitivity, ease in packaging, and flexibility of the shape of the extended gate area. However, most ISFET- or EGFET-related devices have used a separate commercial macro-reference electrode (RE) to provide a stable potential in the electrochemical measurement system. This requirement restricts their convenience and applicability for electrochemical ion sensing measurements.

In 2003, our previous research developed an all solid-state unpackaged planar Ti/Pd/Ag/AgCl/KCl-gel microreference electrode (µRE) with a very high stable potential (drift voltage <1 mV over 30 min), very small offset voltage (0.45 mV), and near-total insensitivity to pH value or Cl⁻ concentration (less than 2-mV variation from pH4 to pH10 and less than 0.25 mV over a KCl concentration range from 0.1 to 0.6 M).18,19 However, the potential stability of the unpackaged Ti/Pd/Ag/AgCl/KCl-gel µRE degraded after it was in operation for more than 1 h because the Cl⁻ ions of the saturated KCl-gel gradually diffused into the sample solution.

To effectively seal the agarose-stabilized KCl-gel layer and simultaneously reserve a miniature liquid junction on the planar Ag/AgCl µRE, we developed a novel chip-level packaging technique in our previous research.20 Two wafers were used in that research: the first was referred to as the “KCl-gel cap sealing wafer” (with a micromachined cavity filled with KCl-gel and a microliquid-junction aperture) and the second wafer was denoted as the “Ti/Pd/Ag/AgCl quasi-reference electrodes (QREs) wafer.” The performance of the proposed Ti/Ag/AgCl/KCl-gel planar solid-state...
reference electrodes is very close to commercial μREs. In this paper, the implemented EGFET-based CO₂ microsensor and Ti/Ag/AgCl/KCl-gel μRE are packaged on a printed circuit board (PCB) substrate to form a miniaturized CO₂ sensing system. The total dimension of the proposed CO₂ sensing system is only 2.8 × 1.5 × 0.1 cm, which is approximately 30 times less than a conventional CO₂ sensing system (which includes a commercial Ag/AgCl RE). All the fabrication processes presented in this study for the EGFET and μRE are compatible with IC and microelectro-mechanical systems (MEMS) technology. Many sensing characteristics of the implemented EGFET-based CO₂ sensing system will be discussed in this research including sensitivity, sensing linearity, hysteresis voltage, and lifetime.

2 Design and Fabrication

As Fig. 1 shows, the EGFET was designed with a 1000/10 μm channel width/length ratio. The areas of the designed extended gate, source, and drain electrodes are equal to 1 × 1 mm, and their distances from the FET active area are the same (1 mm). To implement a high-performance EGFET-based CO₂ microsensor, an extended gate with large area can provide a more uniform surface onto which to coat the CO₂ solid electrolyte membrane and gas permeable membrane. In addition, a longer distance between the sensing area and the FET electrode areas can facilitate the packaging process.

2.1 Fabrication of the Extended Gate Field-Effect-Transistor-Based Carbon Dioxide Microsensor

All of the manufacturing processes that were adopted to implement a low-hysteresis and high-linearity EGFET-based CO₂ microsensor are compatible with standard integrated-circuit planar technology and are very suitable for mass production. The complete fabrication process only requires three photomasks. Three thin films comprised the full structure of the proposed EGFET-based CO₂ microsensor including one insulator layer (SiO₂), three electrodes (Cr/Au) and one CO₂ solid electrolyte membrane/gas permeable membrane. A schematic illustration of the main processing steps is shown in Fig. 2 and is briefly described as follows:

1. Grow a silicon dioxide (0.5 μm) isolation layer on a clean silicon substrate with a high-temperature thermal furnace. Spin coat and pattern 5-μm-thick photoresist (AZ 4620) using photomask #1. Etch the 0.5-μm silicon dioxide layer with a reactive ion-etching system to prepare for the phosphorus ion implantation mask.
2. Utilize a medium current/high energy ion-implantation system to form the source/drain regions of the EGFET device. The energy and dose of implanted phosphorus ions are 70 keV and 2×10¹⁵ cm⁻², respectively. Anneal the sample in a thermal furnace at 1150 °C for 1 h to reduce the implantation lattice damage and increase conductivity.
3. Remove the ion implantation mask layer with hydrofluoric acid etching and re-grow a new silicon dioxide layer (0.03 μm) to form the gate oxide layer of the EGFET. Spin coat a 5-μm-thick photoresist (AZ 4620) layer and use photomask #2 to pattern the source/drain metal contact windows. Etch with BOE etchant.
4. Sequentially deposit 0.02 μm Cr and 0.15-μm Au thin films onto the wafer using an electron beam evaporator. Spin coat a 5-μm-thick photoresist (AZ 4620) layer and use photomask #3 to define the source/drain/gate electrodes. Electrodes are delineated by wet etching in Au etchant (3% I₂: 40% KI: 57% H₂O₂ and Cr etchant (Cr-7T).
5. Wire bond six enameled wires to the five drain electrode pads and one common source electrode pad. Assemble a package chip (which was made by KOH etching) on the EGFET chip to isolate the electrical parts of the proposed EGFET-based Cl⁻ microsensors from the test solution.
6. Prepare the CO₂ solid electrolyte membranes by mixing 4 wt% PVA, 5 mM carbonic anhydrase (from bovine erythrocytes), 10 mM NaHCO₃ and 0.5 mM NaCl. Coat the CO₂ solid electrolyte membrane materials onto the EGFET sensing area and evaporate the solvent off slowly at room temperature over a period of 24 h. Prepare the CO₂ gas permeable membranes by mixing 77.7 wt% RTV 3440, 0.8 wt% valinomycin and 21.5 wt% DOS. Dissolve this chemical composition into 1 ml of THF solution. Coat the ion-selective membrane materials onto the CO₂ solid electrolyte membrane and evaporate the solvent off slowly at room temperature over a period of 24 h.

2.2 Reagents
Polymer vinyl alcohol was purchased from Fluka. Sodium bicarbonate (NaHCO₃), sodium chloride (NaCl), tetrahydrofuran (THF), Bis(2-ethylhexyl) Sebacate (DOS), and carbonic anhydrase (from bovine erythrocytes) were purchased from Alfa Aesar. Silicone rubber (RTV 3440) and valinomycin were purchased from Dow Corning Co. Ltd., Midland, Michigan, and Sigma-Aldrich, respectively.

2.3 Fabrication of the Ti/Ag/AgCl/KCl-Gel Microreference Electrode
As Fig. 3(a) shows, a thin film Ti/Ag/AgCl QRE was developed for this work where the titanium layer is used to improve surface adhesion. In the fabrication of the QRE, integrated circuit processing technology and lift-off techniques were utilized to deposit and pattern the multilayer metals. The Ti (60 nm) layer was electron-gun evaporated first in sequence and without breaking the vacuum to avoid oxidation of the titanium film. Next, a Ag layer was DC-sputtered onto the Ti layer. Our research determined that a 4-μm-thick Ag layer worked reasonably well. Chlorination of the silver electrodes was carried out electrochemically in a 0.1 M HCl (J. T. Baker) solution by applying either a constant voltage of 1.0 V or a constant current of several tens of mA. Therefore, chlorination of the silver surface proceeded in the constant current mode using a current density of 1 mA/cm² for 10 min.

The cross-sectional diagram of the KCl-gel cap sealing wafer is displayed in Fig. 3(b). The two bulk-micromachined...
silicon cavities were designed for the conducting-epoxy/UV-glue encapsulated electrical conduction wire and the KCl-gel sealing cap, respectively. The window size of the KCl-gel trapezoid cavity is $4 \times 4 \text{ mm}$, and the corresponding KCl-gel injection volume in the cavity is $6.40 \mu\text{L}$. However, the dimension of the liquid-junction aperture is fixed at $75 \times 75 \mu\text{m}$, and the window size of the conducting-epoxy/UV-glue sandglass-shaped cavities on both sides of the wafer was kept constant at $2 \times 2 \text{ mm}$.

To enhance the endurance of the Ti/Ag/AgCl QRE against contamination caused by the sample solution and to improve its ability to provide a constant reference potential free from the effects of changing Cl$^-$ ion concentration, an agarose-supported KCl-gel membrane was employed. The KCl-gel membrane not only ionically bridges between the AgCl layer and the sample solution, but also supplies a stable and sufficient Cl$^-$ concentration to the AgCl/KCl-gel/sample solution interfaces to achieve a stable junction potential. In our experiments, the 2 wt% agarose powder was dissolved in a saturated 3 M KCl solution, heated to the agarose melting temperature (150°C), mixed thoroughly and cooled to the gelling temperature ($60^\circ\text{C}$–$70^\circ\text{C}$) prior to dispensation into the “KCl-gel filling cavity” as shown in Fig. 3(a) using the syringe method.

Finally, as Fig. 3(c) shows, a commercial UV-glue was used to seal and bond the KCl-gel filled chip and the wire-connected Ti/Ag/AgCl chip in an ultraviolet (UV) exposure system. The dimensions of the two chips are large enough to be manually aligned and assembled on a microscope working stage. To avoid any melting or vaporization of the KCl-gel, the curing temperature of the UV-glue was controlled at under $25^\circ\text{C}$–$30^\circ\text{C}$. The fabrication yield of the sealing and packaging processes mentioned above is approximately 45% in a lab environment, and the total dimensions of the implemented chip-level packaged planar Ti/Ag/AgCl/KCl-gel μRE module are equal to $9 \text{ mm (L)} \times 6 \text{ mm (W)} \times 1 \text{ mm (H)}$, which is approximately 250 times less than the traditional commercial Ag/AgCl RE (OD = 12 mm and length = 120 mm).

3 Results and Discussions

As shown in Fig. 4(a), the EGFET-based CO$_2$ microsensors and the planar Ti/Ag/AgCl/KCl-gel reference electrode were combined together on a PCB substrate. To facilitate the packaging and testing processes, we produced an array of five EGFET-based CO$_2$ microsensors with the same design on one die ($1.3 \times 1.1 \text{ cm}$), and their source electrodes are connected together as a common source. For each measurement presented in this research, the common source connecting wire was attached to electrical ground. The drain electrodes of the five EGFET-based CO$_2$ microsensors were not connected together and have individual connecting wires; hence, the total number of connecting wires on the chip is...
six (one common source and five drains). This study used a commercial semiconductor parameter analyzer (Agilent B1500A) to characterize the transistor and CO₂ microsensor in standard testing solutions. The test setup utilized in this study is shown in Fig. 4(b). The CO₂ microsensor was immersed into the testing solution. The reference electrode provides a constant voltage in the testing solution and serves as a gate potential to the EGFET. Different ion concentrations will affect the absorbed charge on the ISM surface, and the results appear as various gate voltages on the EGFET.

3.1 Characterization of the Extended Gate Field-Effect-Transistor Device

To examine the basic electrical characteristics of the fabricated EGFET (with a 1000/10-μm channel width/length ratio), the EGFET output current/voltage and gate leakage characteristics were measured with an Agilent B1500A semiconductor parameter analyzer. Figure 5 shows the drain current versus drain voltage (ID – VDS) in the implemented EGFET. In this research, 20 EGFET dies were implemented and characterized. As the gate and drain electrodes are biased at 5 and 8 V, respectively, the drain current of presented 20 EGFETs (with same rectangular channel design) ranges from 8.3 to 8.4 mA. The variation of the drain current is not obvious. Moreover, as the drain and gate electrodes biased at other conditions, the variation of the drain current of presented 20 EGFETs (with same rectangular channel design) is also very small (about 0.1–0.2 mA).

3.2 Characterization of the Planar Ti/Ag/AgCl/KCl-Gel Reference Electrode

Figure 6 shows the scanning electron microscope surface micrographs of the AgCl layer. The porosity of the AgCl layer can have a large influence on the impedance of the μREs, and a higher porosity in the top AgCl layer results in a greater possibility of directly exposing the underlying Ag layer to the KCl-gel solid-state electrolyte, which would cause interference noise through redox reactions. To avoid this situation, the electrochemically chlorinated AgCl layer must contain no gross pores. The chlorination conditions chosen in this study (current density of 1 mA/cm² for 10 min) were able to produce a AgCl layer with a well-controlled grain size of approximately 0.5 – 3.0 μm and with nearly zero porosity.

The stabilities of the voltage potentials for the unpackaged planar Ti/Ag/AgCl QRE and the chip-level packaged and unpackaged planar Ti/Ag/AgCl/KCl-gel μREs were characterized by a potentiometric analysis. The analysis was accomplished by measuring the open circuit potential (OCP) with a two-electrode system in 0.01 M KCl aqueous solution at 25°C over 30,000 s. To test the performance of our fabricated electrodes when used as reference electrodes, the fabricated electrodes were given the role of RE and the commercial Ag/AgCl electrode was the WE in our OCP measurement assembly.

Figure 7(a) shows the OCP variations of chip-level packaged planar Ti/Ag/AgCl/KCl-gel μRE with 6.4 μL of KCl-gel volume compared with a commercial Ag/AgCl RE over 30,000 s of testing time. The measured potential drift of the planar Ti/Ag/AgCl μRE (2.9 mV over 30,000 s) is approximately equal to that of the commercial Ag/AgCl RE (1.6 mV over 30,000 s). Moreover, the offset voltage of the planar Ti/Ag/AgCl μRE (~3.0 mV) is smaller than that of the commercial Ag/AgCl RE (~5.7 mV).

The impedance of a μRE is determined by the resistance of its isolation junction (the liquid junction aperture), which separates the internally filled aqueous KCl or KCl-gel from the sample electrolyte. We built a three-electrode electrochemical cell to measure the impedance and phase shift of three chip-level packaged Ti/Ag/AgCl/KCl-gel μREs at 25°C. The three-electrode cell is composed of a WE (which is our μRE), a platinum CE and a commercial Ag/AgCl RE. The measured absolute values of the impedances are plotted as a function of frequency. The scanning frequency of the small amplitude sinusoidal excitation signal ranges from 0.01 to 100 kHz. Figure 7(b) shows that the impedance measured at 1 kHz of the solid-state planar μRE is approximately 3.223 kΩ, which is smaller than that of the commercial Ag/AgCl RE (approximately 3.377 kΩ). A slow diffusion of the filled solution through this junction is necessary for proper electrode operation.
Unfortunately, slower diffusion flow requires a more restricted flow path, and the resistance of the electrolyte along the path will increase. The small impedance of the RE means that little compensation potential is required for the WE and CE. In short, there is a fundamental trade-off between electrode impedance and leakage rate.

The qualification of an electrode to be used as a reference electrode requires not only it can provide a stable chemical potential while immersed in the testing solution, but also it has to provide a stable potential against any variations in Cl$^-$ concentration. Figure 7(c) shows the Ti/Ag/AgCl QRE and the planar Ti/Ag/AgCl/KCl-gel μRE cell potentials calibrated against the Cl$^-$ concentration. The potential variation of presented planar Ti/Ag/AgCl/KCl-gel μRE is only about 0.4 – 0.7 mV/pCl over the range of 0–0.5 M concentration of Cl$^-$ ion. However, as shown in Fig. 8, the proposed CO$_2$ sensor demonstrates a high sensitivity (44.4 mV/decade). Therefore, the influence of final sensitivity testing results on the potential variation of presented planar reference electrode is only about 0.9–1.6% (0.4/44.4 ≒ 0.9%, 0.7/44.4 ≒ 1.6%). Therefore, the proposed μRE can provide a nearly stable potential against Cl$^-$ ion concentration of testing solution.

### 3.3 Characterization of the Extended Gate Field-Effect-Transistor-Based CO$_2$ Microsensor

In the development of a sensing microsystem, microsensing elements with high sensitivity and high sensing linearity can facilitate the design and reduce the fabrication cost of the signal processing circuits. Figure 8 shows the measured gate voltage of the fabricated EGFET-based CO$_2$ microsensor in a standard testing solution with six different CO$_2$ concentrations (0.25 to 50 mM). Each testing point represents the test data from five microsensors of the same design. As shown in Fig. 8, very high sensing linearity (98.4%) and high sensitivity (44.4 mV/decade) are obtained in this study. According to the experimental results, the fabricated EGFET-based CO$_2$ microsensor has a response time of 100 s, and its output signal reaches a stable value within 5 min.

To investigate the selectivity of the proposed CO$_2$ sensing system, this paper also measured the gate voltage of the fabricated EGFET-based CO$_2$ microsensor in a standard testing solution with six different dissolved O$_2$ concentrations (0.25 to 50 mM). The measured sensitivity of the proposed CO$_2$ sensing system for varied dissolved oxygen (O$_2$) concentrations is only 4.3 mV/decade, which is much less than that for CO$_2$ gas (44.4 mV/decade). Based on the theory, CO$_2$ and the other gas molecules in aqueous solution can diffuse through the gas permeable membrane into the CO$_2$ solid electrolyte membrane. However, only CO$_2$ molecules can generate a more obvious reaction with the CO$_2$ solid electrolyte membrane and a resulting pH change can be detected by the EGFET microsensor.

Hysteresis is a very important parameter in microsensors that must be characterized; however, few previous studies
have performed the necessary investigations. Low-hysteresis voltages indicate a reliable and repeatable microsensor response. Figure 9 presents a hysteresis characterization of the fabricated EGFET-based CO₂ microsensor. The hysteresis voltages were measured using a standard testing solution with CO₂ concentration altered every 20 m in the sequence of 2.5, 5, 25, 50, 25, 5, 0.5, 0.25, 0.5, and 2.5 mM. A very small hysteresis voltage (7.5 mV) was measured at 2.5 mM.

The long-term stability (lifetime) of the implemented EGFET-based CO₂ microsensor (with the planar Ti/Ag/AgCl/KCl-gel μRE) was also investigated in this work. During the lifetime analysis, the sensor chip is immersed into a standard chloride testing solution with six different CO₂ concentrations (in the range 0.25–50 mM), and each concentration was tested for 5 min. The long-term stability measurement result is shown in Fig. 10. The total testing time over a single day was approximately 25 min, and the sensor chip was stored under dry conditions at room temperature in the periods between tests.

During 30 days of measurement, the implemented EGFET-based CO₂ microsensor (with the planar Ti/Ag/AgCl/KCl-gel μRE) demonstrated a very stable sensitivity (varied only from 43.7 to 44.4 mV/decade) and linearity (varied from 97.8% to 98.37%); hence, the lifetime of the presented EGFET-based CO₂ sensor is more than 30 days.

Finally, as Table 1 shows, we compared the five sensing characteristics (sensitivity, sensing linearity, linear range, hysteresis voltage, and response time) addressed in this study in the optimum compositions with those in the previous literature. The implemented EGFET-based CO₂ sensing system with a packaged μRE presents the highest sensitivity, the widest linear range, and the fastest response time in those CO₂ microsensors. Substantially, the EGFET-based CO₂ microsensor developed in this study demonstrates a moderate sensitivity (44.4 mV/decade), a very high sensing linearity (98.37%), a wide linear range (0.25–50 mM) and a very low-hysteresis voltage (7.5 mV).

4 Conclusion

In this paper, the design, fabrication, and performance characterization of a high-performance EGFET-based CO₂ sensor integrated with a planar Ti/Ag/AgCl/KCl-gel reference electrode were presented. All of the fabrication processes are compatible with IC and MEMS technologies. The EGFET-based microsensor has a rectangular gate (1000/10 μm channel width/length ratio), its extended gate area is coated with a CO₂ solid electrolyte membrane and a gas permeable membrane. The device demonstrated a very high sensitivity (44.4 mV/decade) and very high sensing linearity (98.37%), with sensing CO₂ concentrations ranging from 0.25 to 50 mM. Furthermore, a very small hysteresis voltage (7.5 mV) was obtained over the cycle 2.5 mM–5 mM–25 mM–50 mM–25 mM–5 mM–25 μM; this result was achieved by improving the surface planarization and enlarging the sensing area of the EGFET to 1 × 1 mm.

Acknowledgments

The authors would like to thank the National Science Council and National Sun Yat-sen University of the
Republic of China, Taiwan, for financially supporting this research under Contract Nos. NSC 101-2221-E-110-080, NSC 102-2221-E-110-078, and EI-28-05-10-101. The authors are indebted to the National Nano Device Laboratories (NDL) in Taiwan for their assistance in providing access to their processing facilities.

References


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